



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4813

<b>SERIAL NUMBER</b> 10/797,577	<b>FILING OR 371(c) DATE</b> 03/11/2004 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> 403003/TAKADA
------------------------------------	---	---------------------	-------------------------------	---

## APPLICANTS

Satoshi Kume, Ibaraki, JAPAN;  
 Nobuyuki Hishinuma, Hyogo, JAPAN;  
 Hiroshi Sugahara, Hyogo, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

*none*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-081776 03/25/2003 *hm*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/26/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 14	<b>INDEPENDENT CLAIMS</b> 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>hm</i> Examiner's Signature <i>hm</i> Initials				

## ADDRESS

23548

## TITLE

*hm*  
 5/10/07  
 Ultraviolet-light radiating apparatus <sup>and</sup> wet etching apparatus and wet etching method using ultraviolet light, and method of manufacturing semiconductor device

<b>FILING FEE RECEIVED</b> 986	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit